

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S55	257867	damascene or interconnect	US-PGPUB; USPAT	OR	ON	2006/09/05 13:58
S56	4837	S55 and ((silicon near3 carbide carborundum SiC) same (dielectric or insulat\$7))	US-PGPUB; USPAT	OR	ON	2006/09/05 13:58
S57	1119	S56 and (reactive near2 ion near2 etch or gas near2 cluster near2 ion near2 beam GCIB RIE)	US-PGPUB; USPAT	OR	ON	2006/09/05 13:58
S58	800	S57 and (CMP Chemical adj Mechanical adj Polishing or Chemical adj Mechanical adj Planarization)	US-PGPUB; USPAT	OR	ON	2006/09/05 14:12
S59	303	S58 and liner	US-PGPUB; USPAT	OR	ON	2006/09/05 14:12